

**Notice of References Cited**

Application/Control No.

09/559,347

Applicant(s)/Patent Under  
Reexamination  
CHEN ET AL.

Examiner

Kevin M Bernatz

Art Unit

1773

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*		Document Number	Date	Name	Classification	
		Country Code-Number-Kind Code	MM-YYYY			
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		Country Code-Number-Kind Code	MM-YYYY				
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**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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